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KANEKO.014AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Minoru Umemoto et al. ) Group Art Unit  
Serial No. : New Application )  
Filed : Concurrently Herewith )  
For : PROCESS OF FORMING )  
ULTRAFINE CRYSTAL LAYER, MACHINE )  
COMPONENT HAVING ULTRAFINE CRYSTAL LAYER )  
FORMED BY THE ULTRAFINE CRYSTAL LAYER )  
FORMING PROCESS, PROCESS OF PRODUCING )  
THE MACHINE COMPONENT, PROCESS OF FORMING )  
NANOCRYSTAL LAYER, MACHINE COMPONENT )  
HAVING NANOCRYSTAL LAYER FORMED BY THE )  
NANOCRYSTAL LAYER FORMING PROCESS, AND )  
PROCESS OF PRODUCING THE MACHINE COMPONENT )  
Examiner : Unknown )

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PRELIMINARY AMENDMENT

Hon. Commissioner  
of Patents and Trademarks  
Alexandria, VA 22313-1450

Dear Sir:

This preliminary amendment is submitted for the above-identified patent application which is entrance of national stage of U.S.A based on International Application No. PCT/JP2004/018650. Please make the following changes: